Overcoming Resolution Limits in Terahertz Spectroscopy

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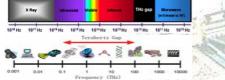




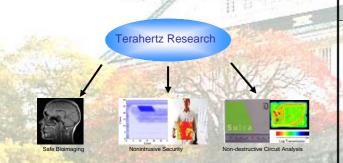
Abstract

Current terahertz technology allows for more efficient imaging methods in fields such as biomedicine and microcircuit analysis. Members at Tonouchi Labs in Osaka University have realized this and have developed a device called a Laser Terahertz Emission Microscope (LTEM) which is capable of detecting terahertz emissions from a device. However, one hurdle faced with terahertz spectroscopy is optical resolution. Optical resolutions at Tonouchi Labs have been limited to approximately 5 microns. The wavelength and the numerical aperture (NA) of an imaging system determine these limits. Thus, installing an objective lens with a high numerical aperture (0.40NA) in the LTEM may possibly improve both resolution and detection in the current system. My research project at Tonouchi Labs entails designing a sample with Au electrode branch pairs on a GaAs substrate. Each branch pair contains a line-space design with diminishing microscopic spatial distances. Projecting a Ti sapphire femtosecond laser throug an API 20x objective lens at these electrodes will cause terahertz waves to be emitted. Hopefully, these improvements to the spectroscopy system will allow image readings to be performed by the LTEM and allow for resolutions under 5 microns.





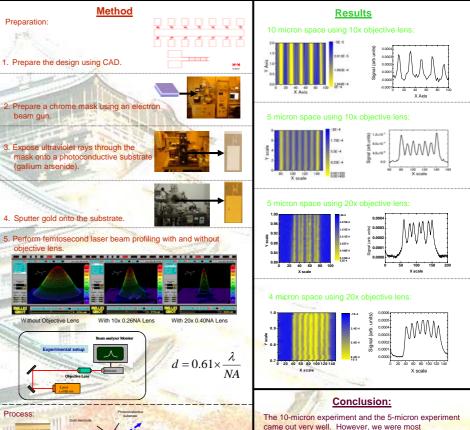
Even a person, who is very unfamiliar with photonics, knows how to turn on a radio, but even most scientists and engineers up to now know very little about phenomena in the terahertz frequency region. Thus, it is called the "Terahertz Gap." The Terahertz Gap, which lies approximately between 3x1011 Hz and 3x1012 Hz, is a frequency range in the electromagnetic spectrum where little is known, but promises to be very beneficial in the future. This is because terahertz radiation posesses some very unique qualities



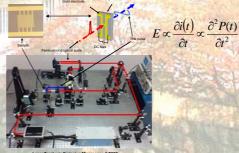
Objectives:

Overcome current LTEM resolution limit of 5u by:

- A. Designing electrodes on GaAs substrate with low spatial widths (10µ-411)
- B. Testing device on LTEM with and without high NA objective lens.
- C. Making any adjustments necessary to sample or LTEM system to achieve higher resolution.



industries.



Process:

- Sample is mounted onto the LTEM. Each electrode branch pair is illuminated by a fs laser.
- Terahertz emission is detected and processed by LTEM.
- Data is plotted by scanning imaging software.
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concerned with attaining resolutions under 5 microns,

and were able to accomplish this task by arriving at a 4micron resolution using the 20x lens, thus, attaining terahertz emission readings that have never been achieved before. Such results will allow for improved readings in fields such as microcircuit analysis. Reaching smaller resolutions may prove to be beneficial, not only to those labs performing terahertz spectroscopy, but hopefully in other areas of photonic research as well. With further testing and improvement, I foresee T-rays becoming the new wave in many